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Docket No.: R2180.0159/P159
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kazunari Kimino

Application No.: 10/609,634

Confirmation No.: 4954

Filed: July 1, 2003

Art Unit: 2814

For: APPARATUS AND METHOD FOR
MANUFACTURING SEMICONDUCTOR
DEVICE

Examiner: Not Yet Assigned

REQUEST FOR RECONSIDERATION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated September 20, 2005, please reconsider the above-identified U.S. patent application based upon the following:

Remarks/Arguments begin on page 2 of this paper.